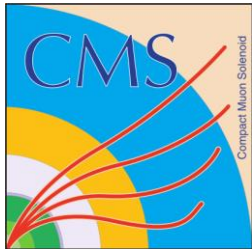


GEM Simulation Studies

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RD51 Collaboration Meeting



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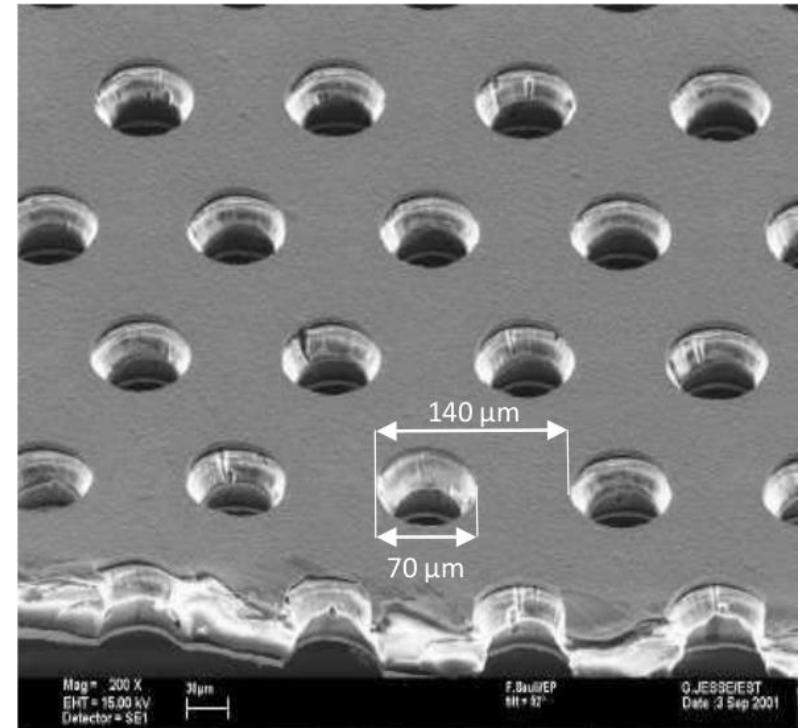
Federal Ministry
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and Research

Overview of activities

- Hole asymmetry or double-mask vs. single-mask foils
 - Gain study of different hole geometry (data and simulation)
- Variation of electric fields
 - Drift, transfer, induction fields
- Long standing issue of lower gain in simulation
 - Investigations on microscopic simulation step
 - ➔ **Discuss studies with a broader audience**

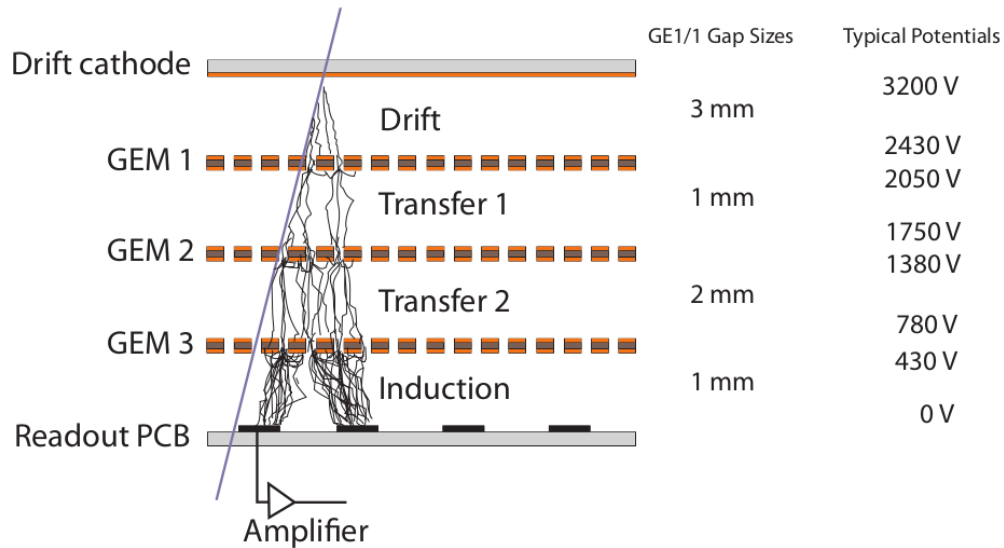
CMS GEM foil design

- Kapton foil as bulk material (50 μm)
- Copper cladded on both sides (5 μm)
- Foil perforated with hexagonal pattern of holes (pitch of 140 μm)
- Double semi-conical holes: standard dimensions 70/50/70 μm (depends on etching procedure)



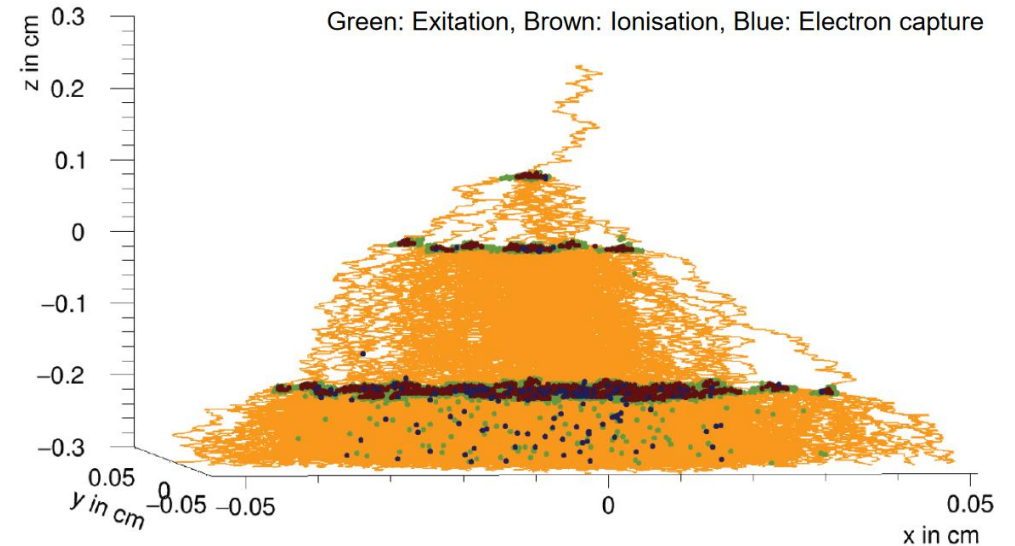
Taken from F. Sauli, "GEM: A new concept for electron amplification in gas detectors"

Triple-GEM simulation



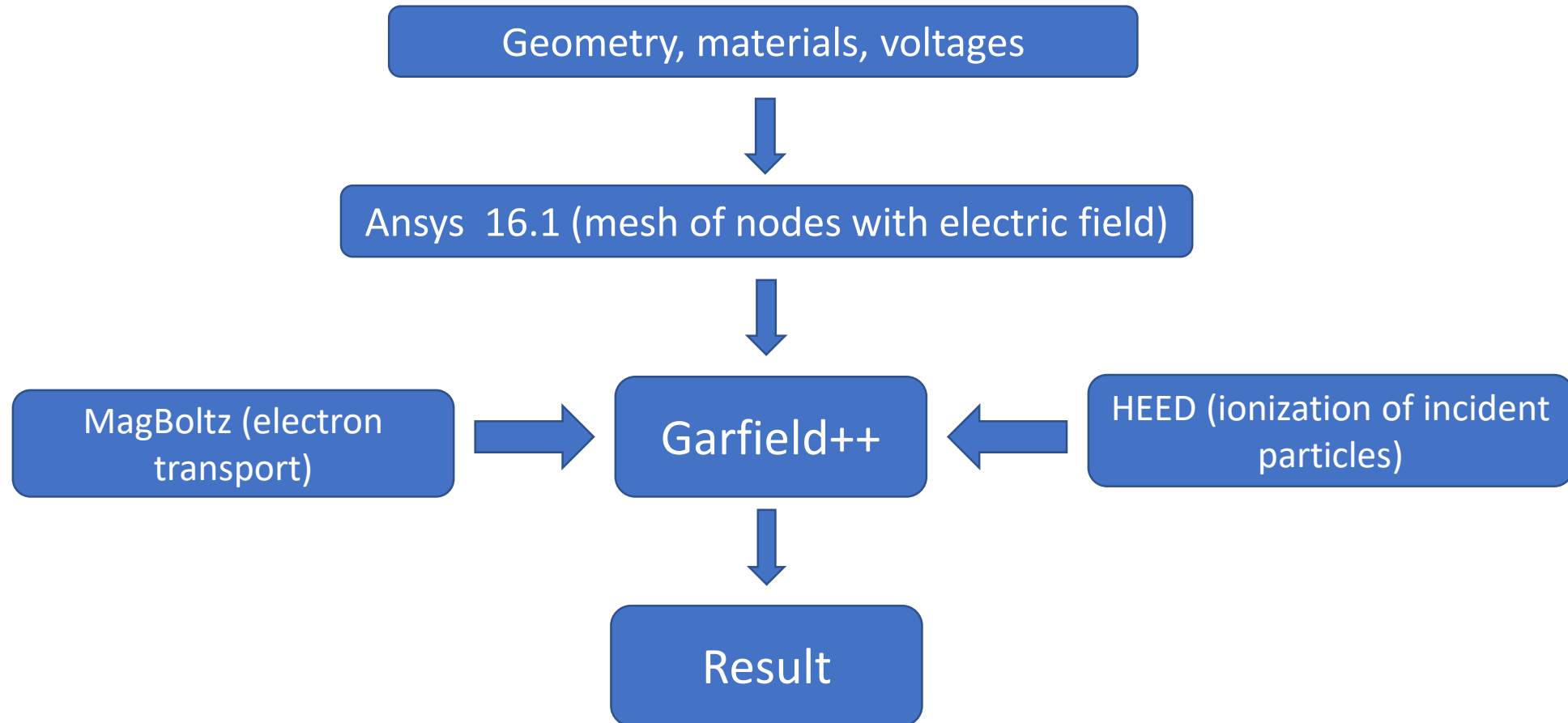
Taken from CERN-LHCC-2015-012

- Triple-GEM detector
- Spacing of 3/1/2/1 mm
- Gas mixture: Ar/CO₂ (70/30)
- Nominal voltages for CMS GE1/1 configuration shown



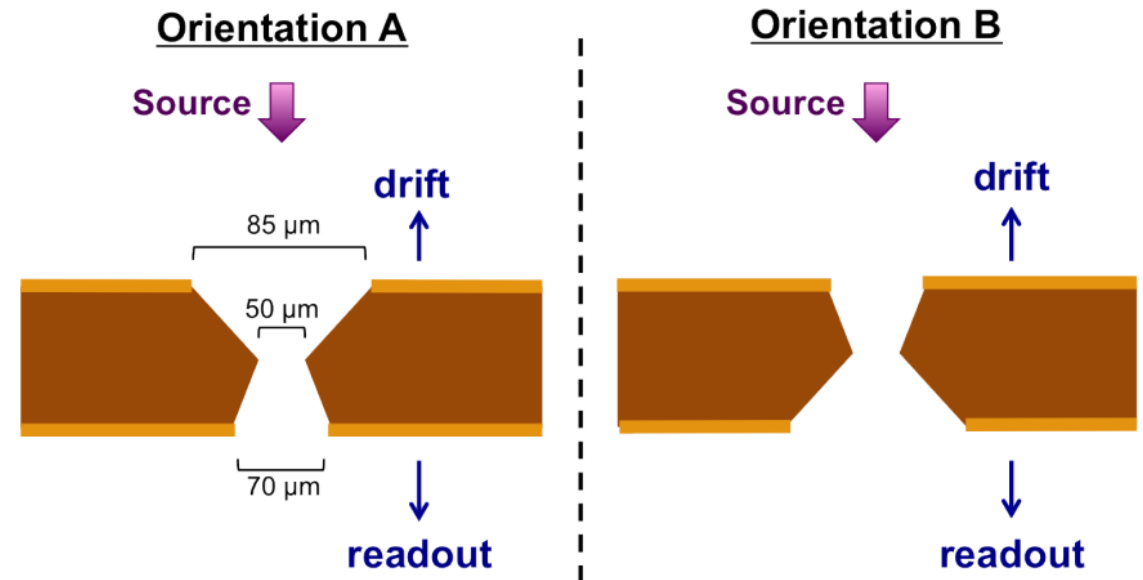
- Electron avalanche in triple-GEM detector
- **Effective gas gain defined as factor between P+S electrons and electrons reaching the readout**

Simulation workflow



Hole asymmetry studies or double-mask vs. single-mask

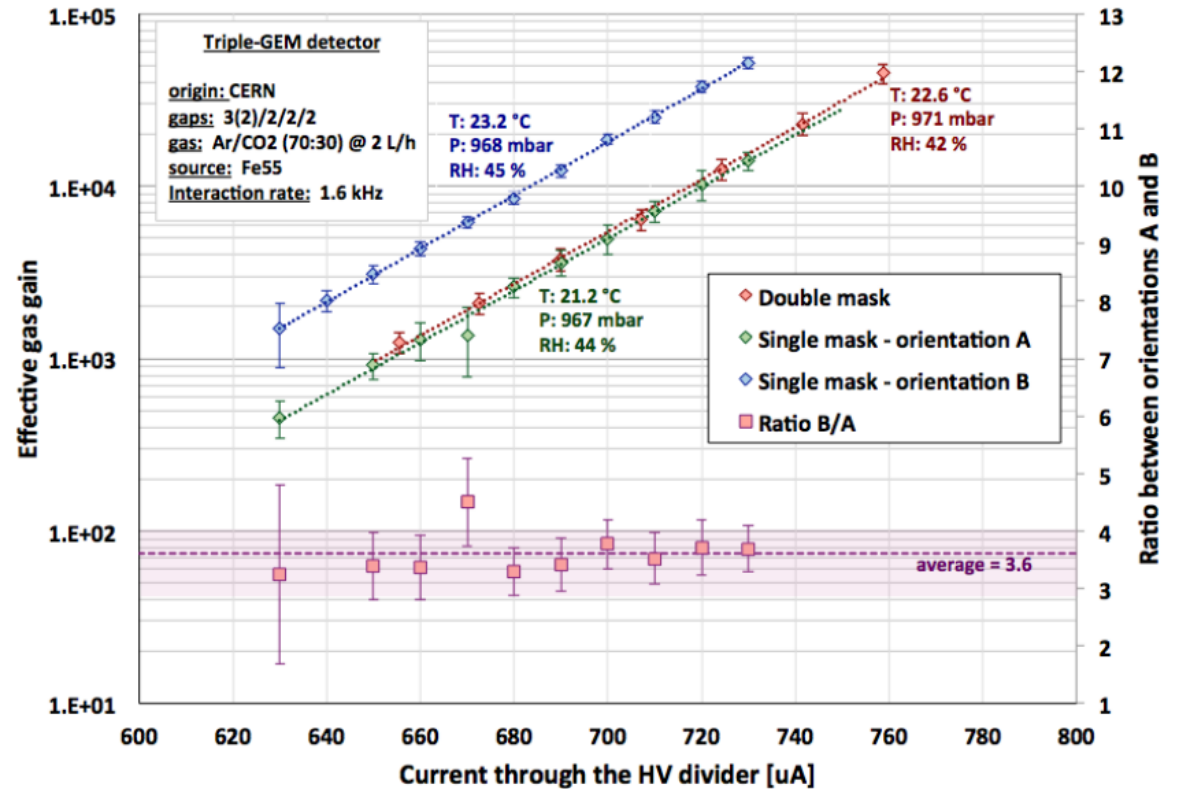
- Hole asymmetry can be introduced by different etching procedures (DM/SM)
- Typical hole geometries
 - SM Orientation A
 - SM Orientation B
 - DM: 70/50/70 μm
- **What is influence on effective gas gain?**



Taken from CERN-THESIS-2016-041 (J. Merlin)

Hole asymmetry studies or double-mask vs. single-mask

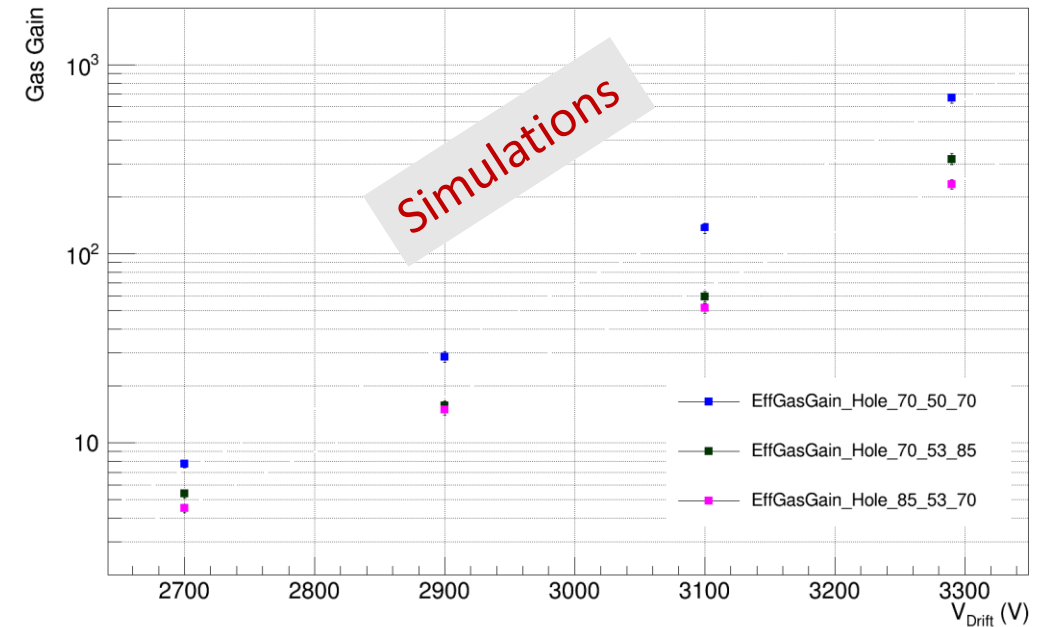
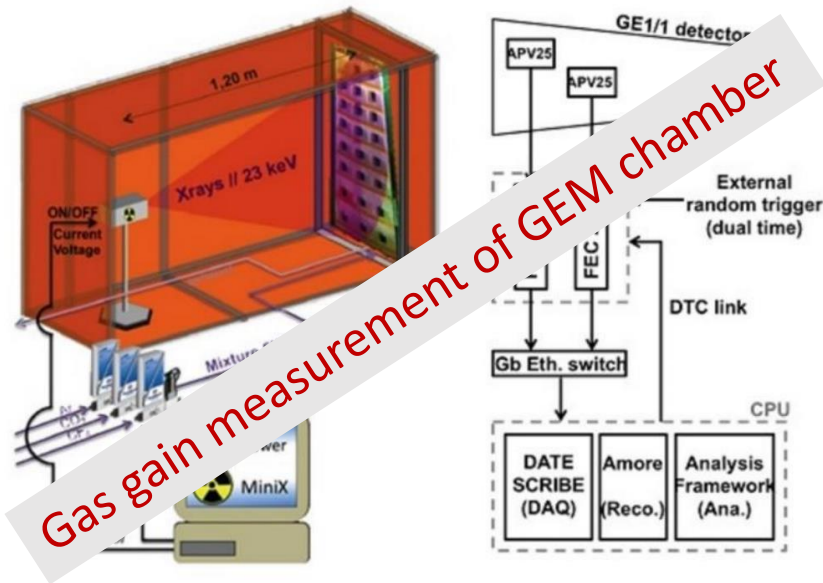
- Studies performed by Jeremie M. et al.
- **Outcome: higher gain for single-mask compared to double-mask**
- Not compatible with simulation results



Taken from CERN-THESIS-2016-041 (J. Merlin)

Hole asymmetry studies or double-mask vs. single-mask

- Studies of influence of hole asymmetry on gas gain ongoing in CMS GEM group
- Provide simulations and measurements



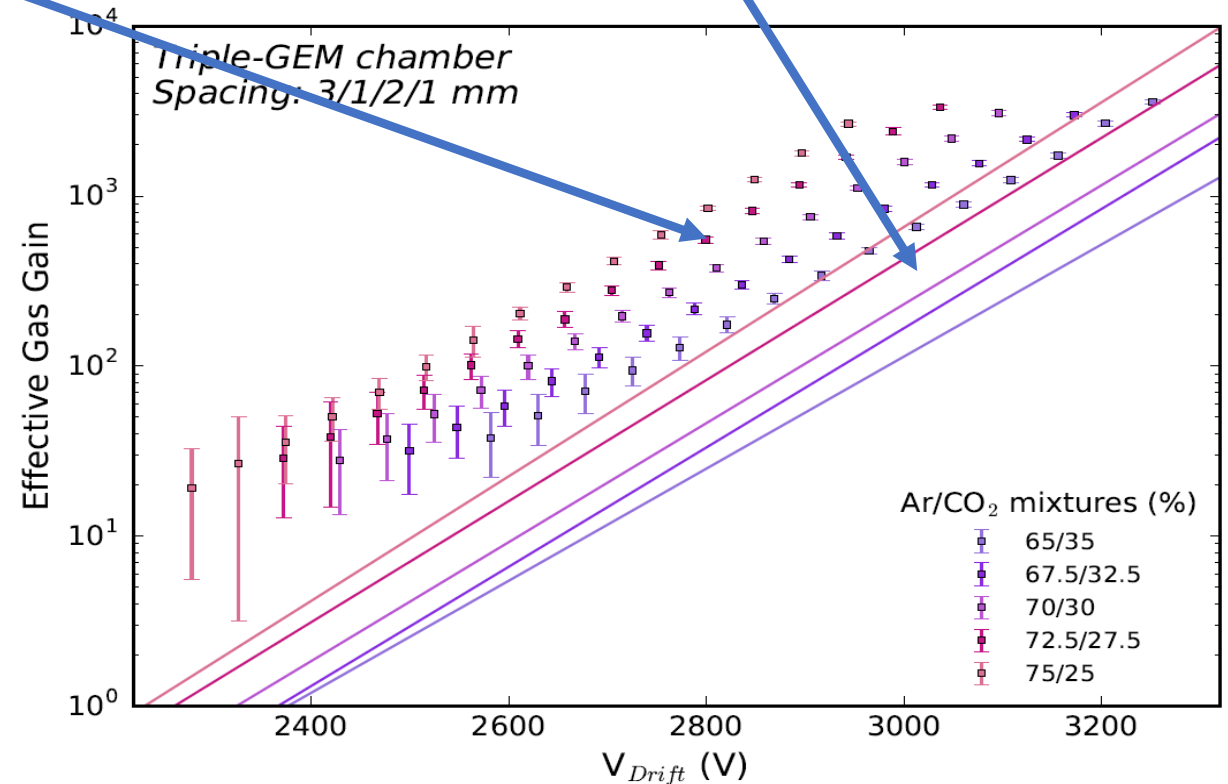
Gas gain measurements

- Experience with gas gain measurements
 - GE1/1 mass production, prototypes, 10x10 chambers
- We have ordered 3 sets of GEM foils for our 10x10 chamber from TECHTRA (specs of 3 μm on hole dimensions)
 - SM with 70/53/85 μm
 - DM with 70/50/70 μm
 - DM with 70/50/85 μm

| GEM number | Holes dimension in copper on the side with number inscription [μm] | Holes dimension in kapton [μm] | Holes dimension in copper on the side without number inscription [μm] | Type pf GEM |
|------------|---|---|--|-------------|
| 1 | 83 | 51 | 70 | Single mask |
| 2 | 83 | 55 | 71 | Single mask |
| 3 | 80 | 51 | 71 | Single mask |
| | | | | |
| 4 | 85 | 53 | 70 | Double mask |
| 5 | 85 | 50 | 70 | Double mask |
| 6 | 86 | 47 | 71 | Double mask |
| | | | | |
| 7 | 69 | 51 | 70 | Double mask |
| 8 | 71 | 48 | 68 | Double mask |
| 9 | 69 | 48 | 70 | Double mask |

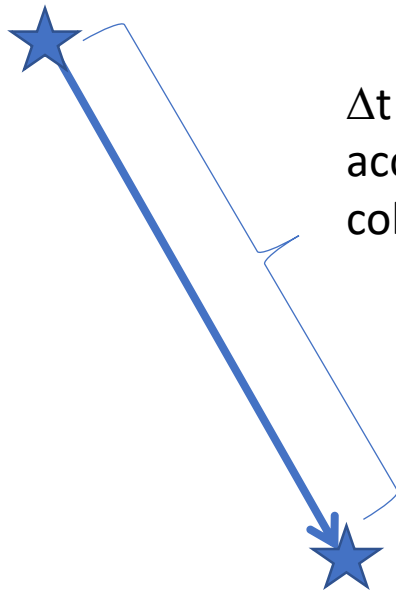
Discrepancy between gain in simulation and measurements

- Well-known feature that simulations give less gas gain than observed in measurements.
- Investigating microscopic simulation step



Time Step in Garfield

Initial point: t_0, x_0



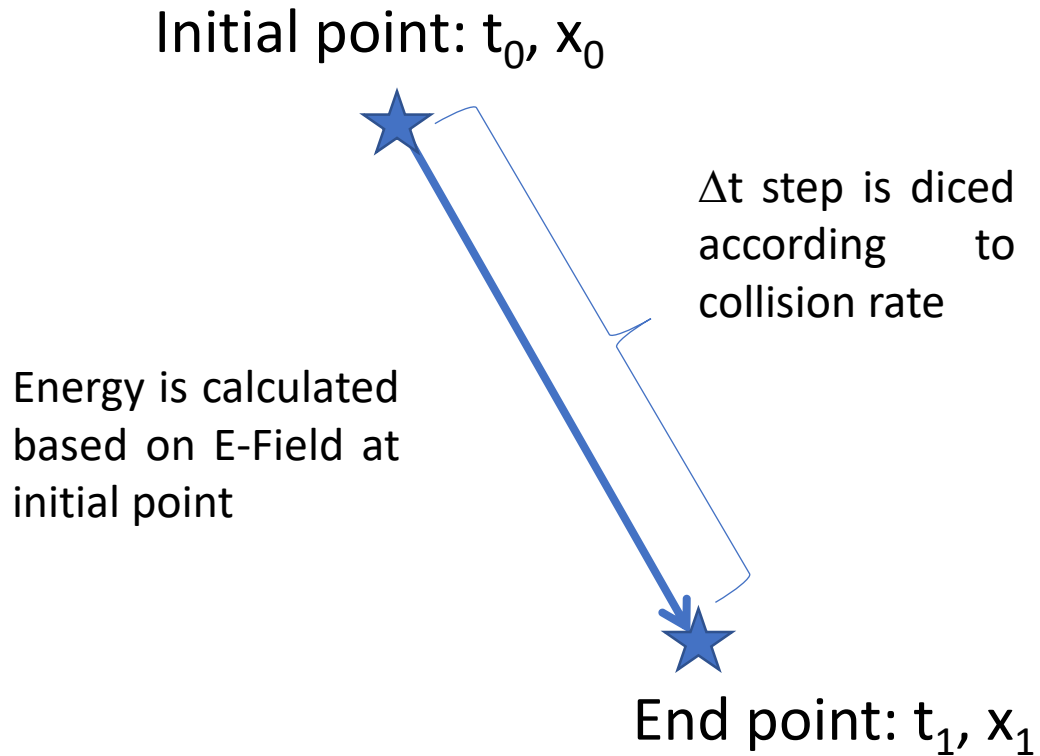
Δt step is diced according to collision rate

End point: t_1, x_1

| Parameter of simulation step | Typical values |
|--|---------------------|
| Time step Δt | 10 ps |
| Distance step ($v_D = 5 \text{ cm}/\mu\text{s}$) | 5 nm |
| Variation of E-Field on that scale (in GEM hole) | 5 V/cm (very small) |

Note: values are typical for drift fields, not for higher electric fields (in GEM hole)

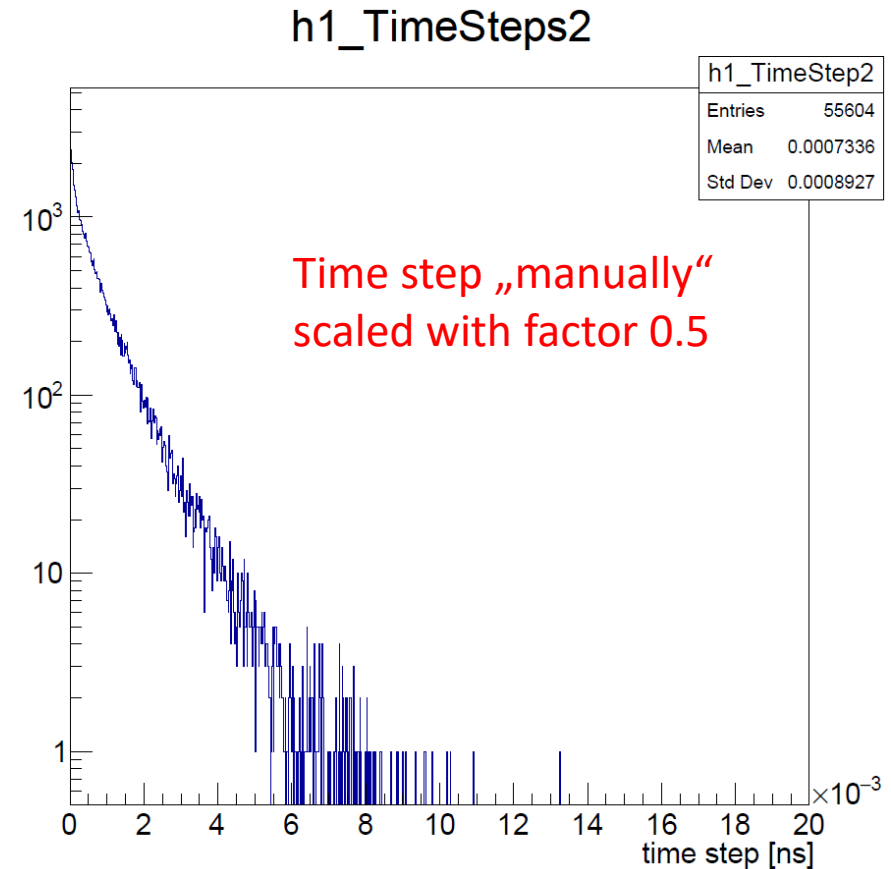
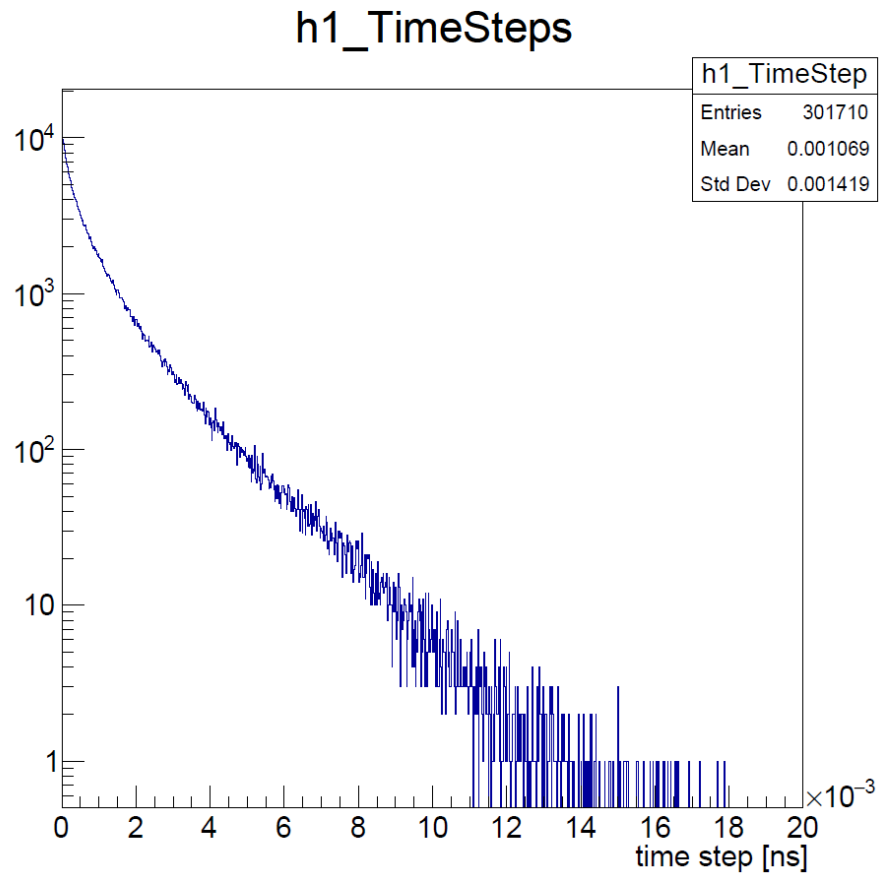
Time Step in Garfield



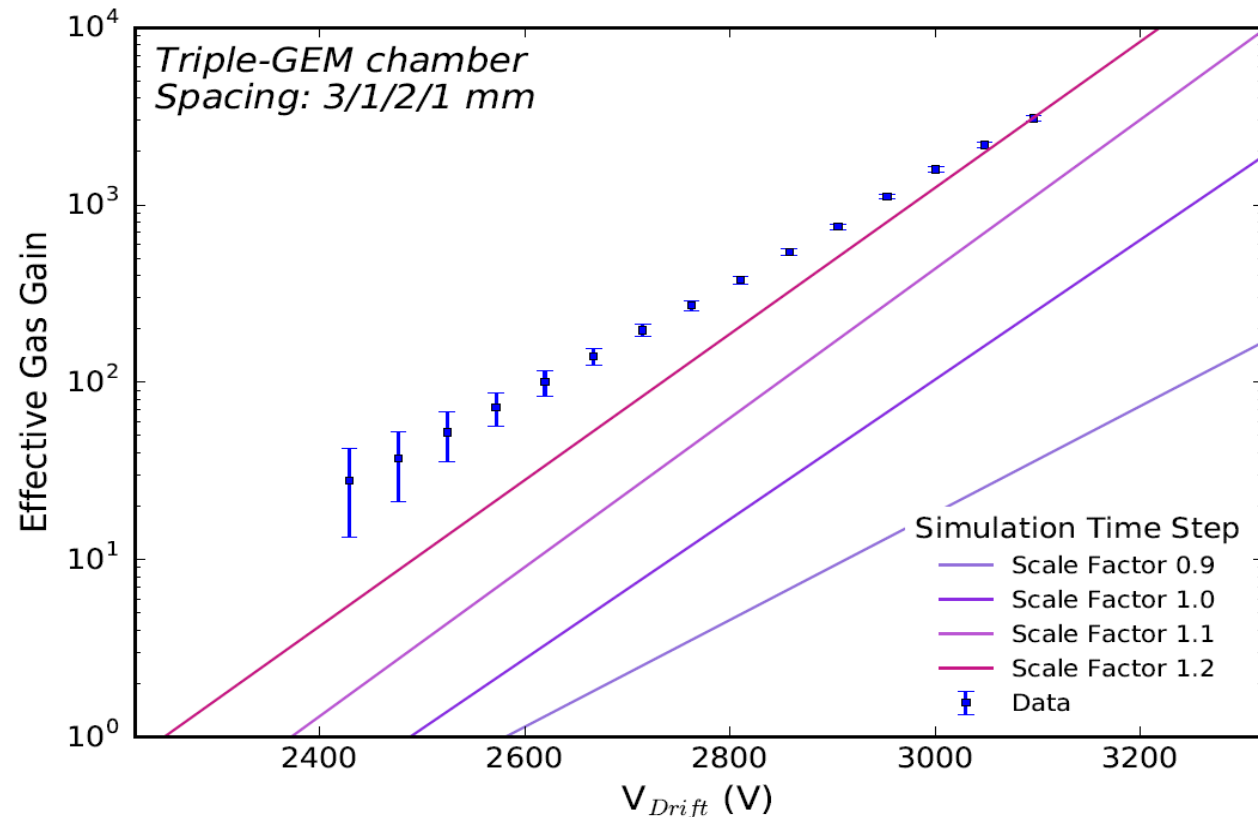
Conclusions:

- Distance step in simulation \ll mean free path
- In code, E-Field is constant for one simulation step
 - Good approximation even inside GEM hole (large variations on small scale)
- Is it good enough though? $\sim 5\%$ error propagates exponentially to absolute gas gain value

Distribution of time step in Garfield



Influence of time step on gas gain



- Smaller time step -> lower gain; larger time step -> higher gain
- First and preliminary comparison of absolute numbers, dependency (slope of exponential) on HV not really matching, more investigations needed...

Summary

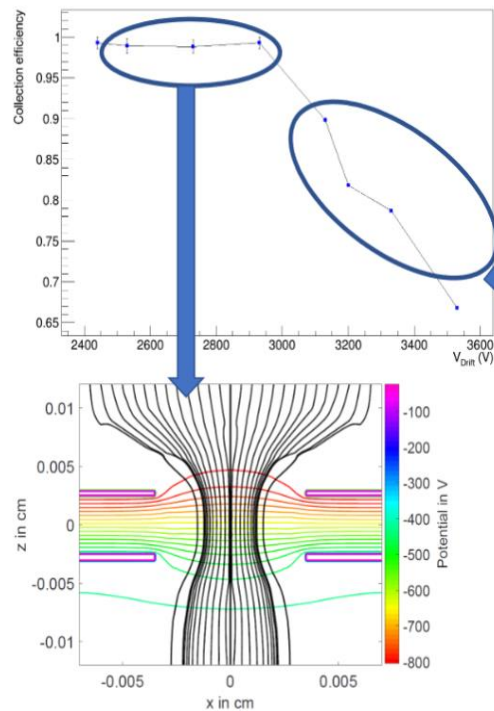
- Gained experience of Garfield++ simulations with single-GEM and triple-GEM configurations
- Studies on hole asymmetry ongoing, results will be ready soon, comparison with lab measurements
- Microscopic simulation step investigated
 - Large dependence of gain on time step observed

Backup

Results from other studies

Variations of V_{Drift}

- Triple-layer GEM simulation



Compare with literature (Sauli et al.):

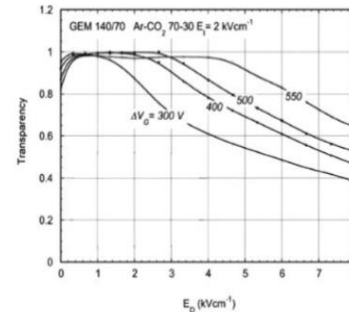
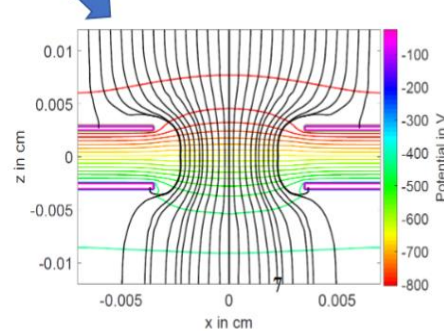
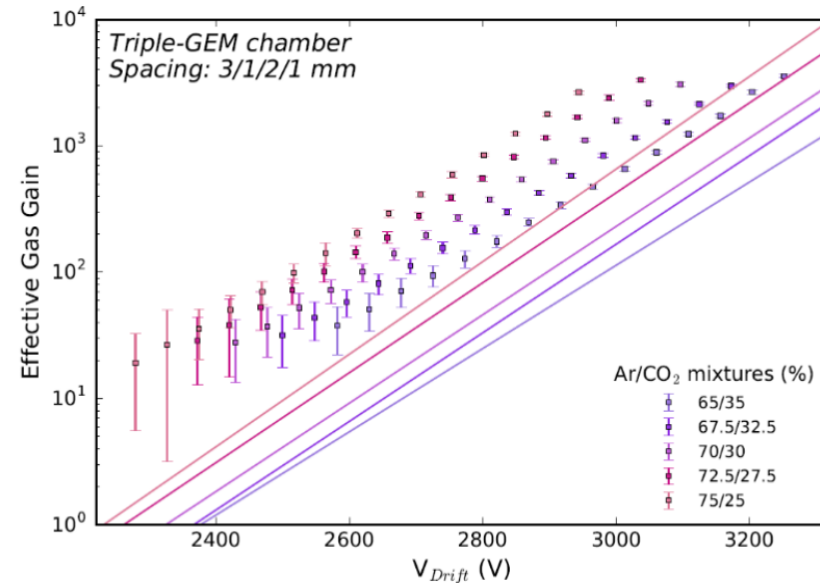


Fig. 6. Electron transparency of a standard GEM electrode (70 μm holes at 140 μm pitch) as a function of drift field for fixed induction field, for several values of GEM voltage.



Comparison: Lab vs. Garfield

- Compare measurements with simulations
- In best case, both sides can benefit
- **First study: Comparison of gas gain for different Ar/CO₂ mixtures as a function of HV**



Points: Data taken with CMS GenV prototype GEM detector
Lines: Exponential fit of Garfield simulations

Details on time step variations

```
...// Determine the timestep.
...double dt = 0.;
...while (1) {
...// Sample the flight time.
...const double r = RndmUniformPos();
...dt += -log(r) * fInv;
...// Calculate the energy after the proposed step.
...if (m_useBfield && b0k) {
...    cwt = cos(wb * dt);
...    swt = sin(wb * dt);
...    newEnergy = std::max(energy + (a1 + a2 * dt) * dt +
...                        a4 * (a3 * (1. - cwt) + vz * swt),
...                        Small);
...} else if (useBandStructure) {
...    const double cdt = dt * SpeedOfLight;
...    newEnergy = std::max(medium->GetElectronEnergy(
...        kx + ex * cdt, ky + ey * cdt,
...        kz + ez * cdt, newVx, newVy, newVz, band),
...        Small);
...} else {
...    newEnergy = std::max(energy + (a1 + a2 * dt) * dt, Small);
...}
...// Get the real collision rate at the updated energy.
...double fReal = medium->GetElectronCollisionRate(newEnergy, band);
...if (fReal <= 0.) {
...    std::cerr << hdr << "Got collision rate <= 0 at " << newEnergy
...        << " eV (band " << band << ").\n";
...    return false;
...}
...if (fReal > fLim) {
...    // Real collision rate is higher than null-collision rate.
...    dt += log(r) * fInv;
...    // Increase the null collision rate and try again.
...    std::cerr << hdr << "Increasing null-collision rate by 5%.\n";
...    if (useBandStructure) std::cerr << "... Band " << band << "\n";
...    fLim *= 1.05;
...    fInv = 1. / fLim;
...    continue;
...}
...// Check for real or null collision.
...if (RndmUniform() <= fReal * fInv) break;
...if (m_useNullCollisionSteps) {
...    isNullCollision = true;
...    break;
...}
...}
...}
```

Scale time step with factors [0.9,1.0,1.1,1.2] here

- Source code Garfield+++
 - Class: AvalancheMicroscopic
 - Function: TransportElectron()